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Dated: April 3, 2009

Electronic Signature for Amy Hagan: /Amy Hagan/

Docket No.: 0042697.00147US2  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Roy G. GORDON et al. Confirmation No.: 5616  
Application No.: 10/520,456 Art Unit: 2813  
Filed: October 19, 2005 Examiner: S. McCall Shepard  
Title: VAPOR DEPOSITION OF TUNGSTEN NITRIDE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NON-FINAL OFFICE ACTION**

Dear Madam:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated January 6, 2009, please amend the above-identified U.S. patent application as follows:

**Listing of claims** begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.